

FORM PTO-1449 (modified)  
To: U.S. Department of Commerce  
(PM&S FORM PAT-1449)  
Patent and Trademark Office

Atty.  
Dkt. No.

M#

Client Ref.

09/743089

275443

C90.04/Q

# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Applicant: WILSON, Craig et al

Appl. No.: New Application

Filing Date: January 5, 2001

Date: January 5, 2001

Page

1

of

1

Examiner: unassigned

Group Art Unit: unassigned

## U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
MC	AR	5 554 588	9/1996	BEHAN et al			
MC	BR	5 420 104	5/1995	HOLZNER et al			
	CR						
	DR						
	ER						
	FR						
	GR						
	HR						
	IR						
	JR						
	KR						
	LR						
	MR						
	NR						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract	Translation Readily Available
						Enclosed	No
MC	OR	1 575 380	9/1980	Great Britain			
MC	PR	126 944	12/1984	Europe	BRUNKE, et al	X	X
	QR						
	RR						
	SR						

## OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

Me	TR	LACOSTE, et al: "LES PROPRIETES ANTISEPTIQUES DE L'HUILE ESSENTIELLE DE LIPPIA SIDOIDES CHAM. APPLICATION A LA MICROFLORE CUTANEE", ANN. PHARMACEUTIQUES FRANCAISES, vol 54, no 5, 1996 pgs 228-230 XP002120135, the whole document			
MC	UR	MORRIS et al: "ANTIMICROBIAL ACTIVITY OF AROMA CHEMICALS AND ESSENTIAL OILS", JOURNAL OF THE AMERICAN OIL CHEMISTS' SOCIETY, May 1, 1979, pgs 595-603, XP000645444, ISSN: 0003-021X, PG 595, para 1-para 3, table III			
MC	WR	FIEDLER: ANTIMIKROBIELLE WIRKUNG VON AROMASTOFFEN UND AETHERISCHE OLE" SEIFEN-OLE-FETTE-WACHSE, vol 107, no 3, 1981, pgs 15-76, XP002120136, pg 75 - pg 76			
	WR				

Examiner M. Cole

Date Considered: 1/03

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.